



AF/2813
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Response
5-29-03
only

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Guoqiang Xing, et al.

Docket No: TI-31729

Serial No: 09/901,416

Conf. No: 7364

Examiner: Thanh T. Nguyen

Art Unit: 2813

Filed: 07/09/2001



For: DUAL HARDMASK PROCESS FOR THE FORMATION OF COPPER/LOW-K INTERCONNECTS

AMENDMENT PURSUANT TO 37 CFR 1.116

Mail Stop AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 5-19-03.

Ann Trent
Ann Trent

OK to Enter
TN

Dear Sir:

Responsive to the Office Action mailed March 24, 2003, in connection with the above identified application, Applicants respectfully submit the following remarks.

RECEIVED
MAY 20 2003
TECHNOLOGY CENTER 2800